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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant(s): Douglas D. Coolbaugh, et al. **Examiner:** Unassigned
Serial No: 10/711144 **Art Unit:** Unassigned
Filed: 8/27/04 **Docket:** BUR920040107US1 (17619)
For: MOS VARACTOR USING ISOLATION WELL **Dated:** August 6, 2004

Commissioner for Patents
Alexandria, VA 23313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.97 and 1.98, it is requested that the following references, which are also listed on the attached Form PTO-1449, be made of record in the above-identified case.

1. European Patent Publication No. EP0902483 A1, published on March 17, 1999;
2. International Patent Publication No. WO 03/043079A1, published on May 22, 2003;
3. Joachim N. Burghartz, et al., "Integrated RF and Microwave Components in BiCMOS Technology", IEEE Transactions On Electron Devices, Vol. 43, No. 9, September 1996 (pp. 1559-1570); and
4. R.A. Moline, et al., "Ion-Implanted Hyperabrupt Junction Voltage Variable Capacitors", IEEE Transactions On Electron Devices, Vol. ED-19, No. 2, February 1972 (pp. 267-273).

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Box 1450, Alexandria, VA 22313-1450 on 8/31/04.

Dated: 8/31/04

P. N. de Haugis
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Applicants are submitting copies of the above-cited references.

Inasmuch as this Information Disclosure Statement is being submitted in accordance with the schedule set out in 37 C.F.R. § 1.97(b), no statement or fee is required.

Respectfully submitted,



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